

Attorney's Docket No.:14580-033001

Amendments to the Specification:

Please replace the title with Method for Producing a Ferroelectric Capacitor that Includes Etching with Hardmasks as suggested in the instant office action.

Please replace paragraph [0046] on page 7, with the following amended paragraph:

[0046] The device is now ready for contact windows (not shown) for the top electrodes 16 of each capacitor 24, 26 to be formed through the interlayer dielectric 38, the cover layers 34 and 36, the encapsulation layers 29, 30, 18, 20 and into the top electrodes 16. These contact windows will then be filled with a contact metal to form a contact between the respective top electrode 16 and an interdevice connection layer laid on the surface of the interlayer dielectric layer 38, using conventional methods. Similarly, a window (not shown) will be cut to the plug 6 which will be lined with a liner and a metal filler inserted into the lined window to establish electrical contact between the bottom electrode 2 and the plug 6. The liner and the filler will then be etched back to leave just the metal contact between the bottom electrode 4 2 and the plug 6.